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## \*BIBDATASHEET\*

Bib Data Sheet

CONFIRMATION NO. 7258

SERIAL NUMBER 10/660,053	FILING DATE 09/11/2003  RULE	CLASS 438	GROUP ART UNIT 2823	ATTORNEY DOCKET NO. 1111.68332
<b>APPLICANTS</b>  Hideaki Takizawa, Kawasaki-shi, JAPAN;  Shougo Hayashi, Kawasaki-shi, JAPAN; Takeshi Kinjo, Kawasaki-shi, JAPAN; Makoto Tachibanaki, Kawasaki-shi, JAPAN; Kenji Okamoto, Kawasaki-shi, JAPAN;				
** CONTINUING DATA *****		yes K.N.		
This application is a DIV of 10/080,108 02/21/2002 PAT 6,767,754 which is a DIV of 09/005,176 01/08/1998 PAT 6,406,946 which is a CON of 08/669,272 05/29/1996 PAT 5,742,074				
** FOREIGN APPLICATIONS *****		yes K.N.		
JAPAN 07-134400/1995 05/31/1995				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/03/2003				
Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged		STATE OR COUNTRY JAPAN	SHEETS DRAWING 29	TOTAL CLAIMS 40
Examiner's Signature Initials		INDEPENDENT CLAIMS 8		
<b>ADDRESS</b> Patrick G. Burns, Esq. GREER, BURNS & CRAIN, LTD. Suite 2500 300 South Wacker Drive Chicago , IL 60606				
<b>TITLE</b> Thin film transistor matrix device and method for fabricating the same				
<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing )				